materials

MDPI

Type of the Paper (Article)

Piezoresistive Multi-Walled Carbon Nanotube/Epoxy Strain Sensor with Pattern Design

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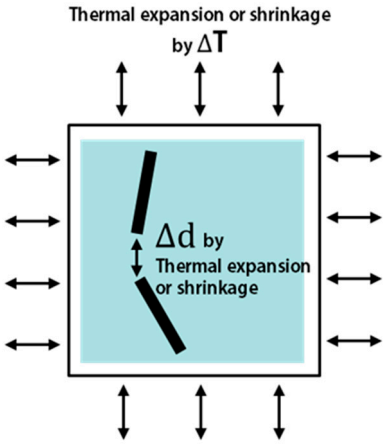


Figure S1. Variation in distance between particles due to thermal expansion or contraction of polymer according to temperature change.

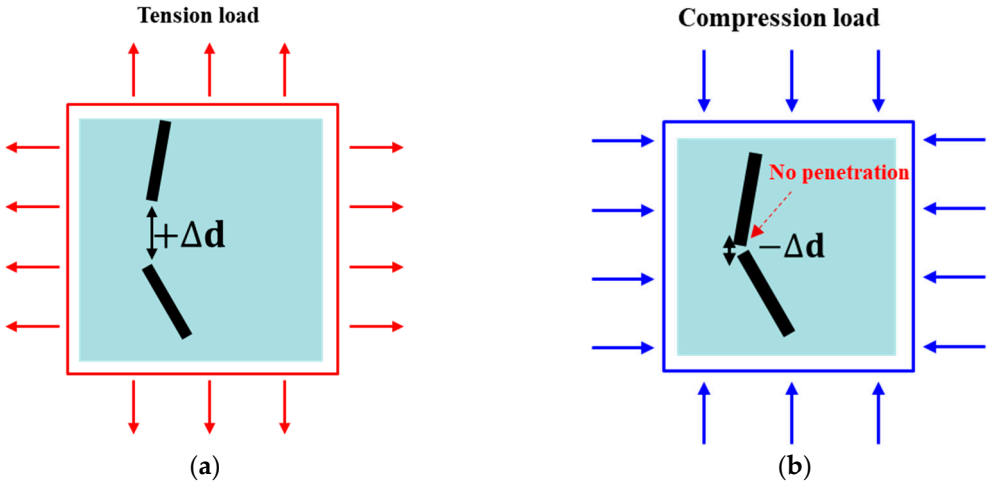


Figure S2. Operating mechanism of composite strain sensor by resistivity (**a**) under tension load and (**b**) compression.

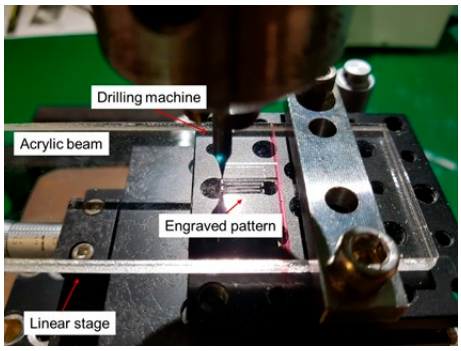
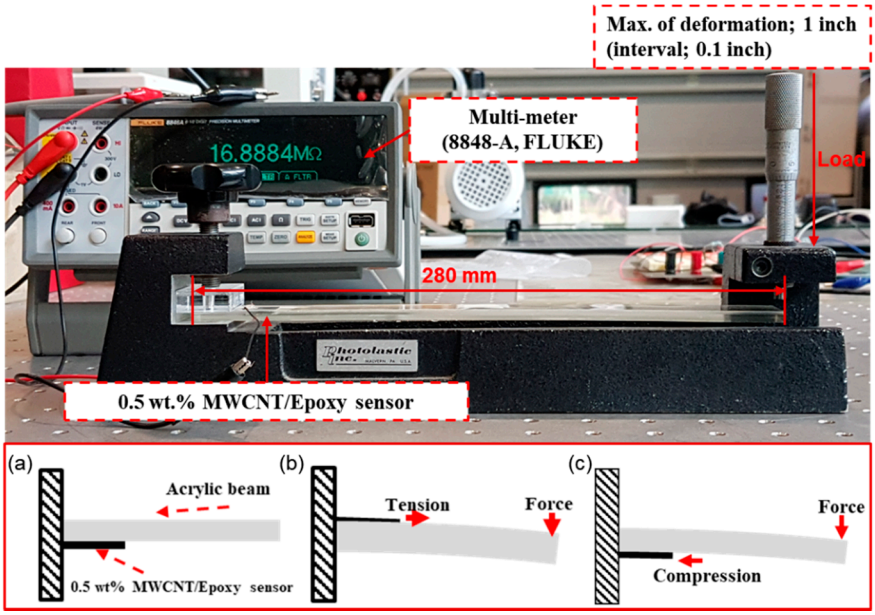
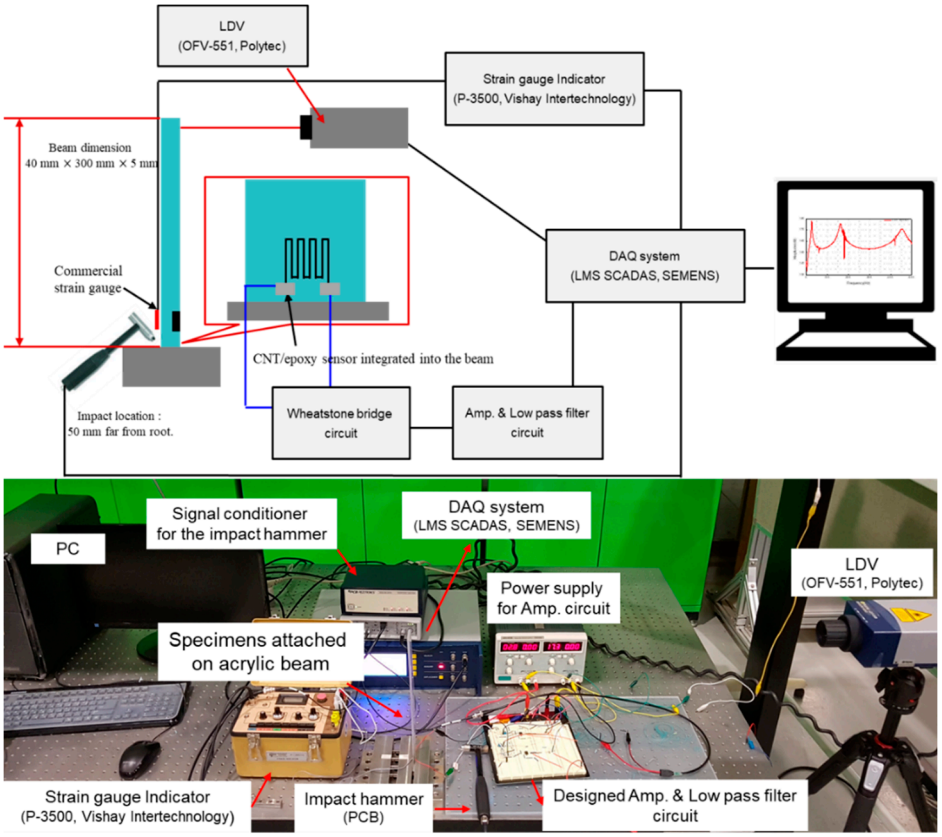


Figure S3. Engraved pattern made by drilling machine and linear stage for making constant pattern.

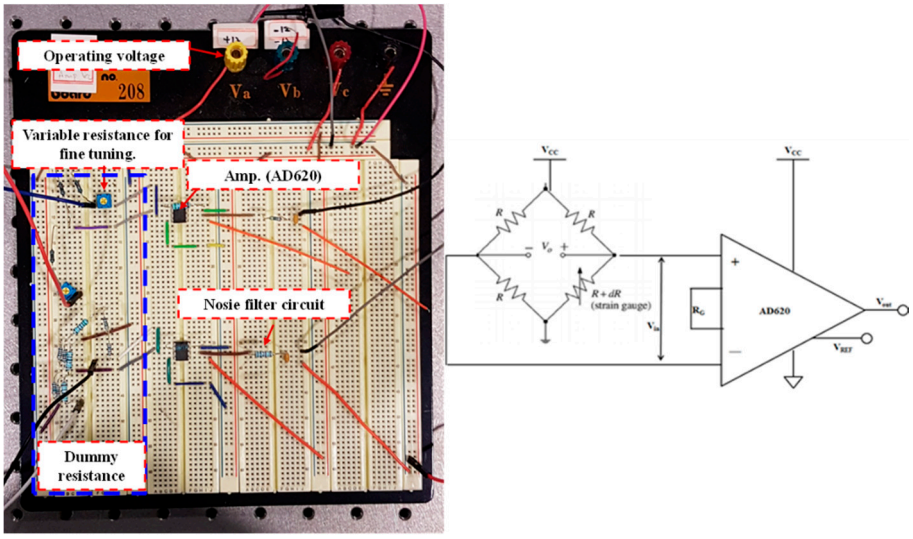


A

Figure S4. Resistance variation of MWCNT/epoxy composite strain sensor when deflection occurs at beam end: (**a**) stead state, (**b**) tension direction, and (**c**) compression direction.



21 **Figure S5.** Experimental setup for testing measurement frequency response of sensor under free
22 vibration of acrylic beam.



23 **Figure S6.** Amplifier circuit by non-inverter amplification for signal processing and Wheatstone
24 bridge circuit for stabilizing output voltage generated by sensor.